



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 5694

| SERIAL NUMBER | FILING or 371(c) DATE | CLASS | GROUP ART UNIT | ATTORNEY DOCKET NO. |
|--|---|--|--|---|
| 10/721,225 | 11/26/2003 | 438 | 1792 | INF 2004 SP 00115 US |
| RULE | | | | |
| APPLICANTS Joern Luetzen, Dresden, GERMANY; Albert Birner, Dresden, GERMANY; Stephan Kudelka, Ottendorf-Okrilla, GERMANY; Helmut Tews, Munich, GERMANY; Rolf Weis, Dresden, GERMANY; | | | | |
| ** CONTINUING DATA ***** | | | | |
| ** FOREIGN APPLICATIONS ***** GERMANY 102 55 866.3 11/29/2002 | | | | |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/25/2004 | | | | |
| Foreign Priority claimed 35 USC 119(a-d) conditions met Verified and Acknowledged | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No /BINH X TRAN/ Examiner's Signature | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY GERMANY | SHEETS DRAWINGS 8 |
| | | | TOTAL CLAIMS 20 | INDEPENDENT CLAIMS 2 |
| ADDRESS SLATER & MATSIL LLP 17950 PRESTON ROAD SUITE 1000 DALLAS, TX 75252 UNITED STATES | | | | |
| TITLE Method and structures for increasing the structure density and the storage capacitance in a semiconductor wafer | | | | |
| FILING FEE RECEIVED 1960 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit |